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U.S. Patent Documents

<u>Examiner Initial*</u>	<u>Patent Number</u>	<u>Issue Date</u>	<u>Patentee</u>
—	AA		
—	AB		

Foreign Patent Documents

	<u>Document Number</u>	<u>Pub. Date</u>	<u>Country</u>	<u>Translation</u>
—	A			
—	A			

Other Documents

(including Author, Title, Pertinent Pages, date and place of publication)

JS

A

Magnetic Bearing Stages for Electron Beam Lithography
Thesis Document
Author: Paul Thomas Konkola
February 1998
Massachusetts Institute of Technology

JS

B

Magnetic Bearing Stages for Electron Beam Lithography
Author: Paul Thomas Konkola and David L. Trumper
As noted on Pages 2-7: Submitted to the 8th International
Symposium on Magnetic Bearings, Mito, Japan, August 26-
28, 2002.

This paper is available over the Internet:
http://web.mit.edu/konkola/www/pubs/ismb02_ptk.pdf

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